Please Enter this amendment.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Hidemasa KAI Art Unit: 1792

Application Number: 10/626,675 Examiner: Ram N. Kackar

Filed: July 25, 2003 Confirmation Number: 1831

For: EPITAXIAL WAFER PRODUCTION APPARATUS AND SUSCEPTOR

STRUCTURE

Attorney Docket Number: 030901 Customer Number: 38834

December 22, 2009

Customer Number:

AMENDMENT UNDER 37 C.F.R. § 1.116 EXPEDITED PROCESSING REQUESTED

Mail Stop: AF Commissioner for Patents P.O. Box 1450 Alexandria. VA 22313-1450

Sir:

This paper is filed (along with a petition for a one-month extension of time) in response to the Office Action dated August 20, 2009. The PTO was closed on December 20 (Sunday) and 21 (USPTO closed due to inclement weather).

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 4 of this paper.